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CEDC 1002
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Dennis R. Christensen
Serial No. 10/706,239
Filed November 12, 2003
Confirmation No. 6388
For VAPOR DEPOSITION APPARATUS

Art Unit 1773

April 13, 2005

COMMISSIONER FOR PATENTS
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SIR:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicant submits the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

Applicant submits herewith copies of the foreign patent documents and literature references.

I certify that each item contained in this Supplemental Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Respectfully submitted,

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PTO/SB/08A			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/706,239	
			Filing Date	November 12, 2003	
			Confirmation Number	6388	
			First Named Inventor	Dennis R. Christensen	
			Group Art Unit	1773	
			Examiner Name	Bret P. Chen	
Sheet	1	of	1	Attorney Docket No.	CEDC 1002

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
		Number	Kind Code ² (if known)				
	26	4,276,855		Seddon et al.	07-07-1981		
	27	6,086,952		Lang et al.	07-11-2000		
	28	2002/102400		Gorokhovskiy et al.	08-01-2002		
FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office	Number ⁴	Kind Code ² (if known)			
	29	EP	1 119 022		Hitachi, Ltd.	07-25-2001	
OTHER ART - NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.					T ⁶
	30	European Search Report, February 25, 2005, 4 pages					

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached.

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